

MODEL PARAMETERS:

SiO_2 thickness = 0.106 μm
 ITO thickness = 0.056 μm
 Polysilicon thick = 0.020 μm
 T = 143.1 K = -130.0 C

- Model (red end, no abs)
- Model (blue, drop-dead abs in poly)
- Model (blue, reflectivity)
- Lick QE measurements (photon transfer method gain calibration)
- ✖ (1 – Re ectivity), Lick measurements

